

Modeling in semiconductor electronics

Javor, A.; **Rang, Toomas**; Szekely, V.; Tamay, K.; **Velvre, Enn** 1993 https://www.ester.ee/record=b1031052*est

Thermal activation and pozzolanic reactivity of Estonian clays for cementitious applications

Yörük, Can Rüstü; Adegbile, Ademola Michael; Tuisk, Tanel; Hain, Tiina; Uibu, Mai; Usta, Mustafa Cem; Trikkell, Andres

JTACC+V4 2025 : 4th Journal of Thermal Analysis and Calorimetry Conference & 10th V4 (Joint Czech-Hungarian-Polish-Slovak)

Thermoanalytical Conference : Book of Abstracts 2025 / p. 70 <https://static.akcongress.com/downloads/jtacc/jtacc2025/jtacc2025-boa.pdf>